

Application No.	Applicant(s)	
10/611,623	HSIAO ET AL.	
Examiner	Art Unit	
Paul D Kim	3729	

SEARCHED				
Class	Subclass	Date	Examiner	
29	603.07 603.09 603.11 603.13 603.15	12/20/2004	PK	
	603.18 605			
	606 609	V		
324	309-314 31 8	12/20/2004	PK	
	322 525			
	526 528	$\overline{}$		
360	313 319	12/20/2004	PK	
	321-324			
427	127,128	12/20/2004	PK	
451	5,41	12/20/2004	PK	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SAME AS	S ABOVE	5/3/2005	PK	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Reviewed Parent Application 09/753804 US PAT. 6,678,127	12/20/2004	PK	
Text Search EAST/NPL (IEEE)	12/20/2004	PK	
Updated Text Search EAST	5/3/2005	PK	